

Notice of References Cited	Application/Control No. 09/882,141	Applicant(s)/Patent Under Reexamination WANG ET AL.4	
	Examiner Lynette T. Umez-Eronini	Art Unit 1765	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-4208241	06-1980	Harshabarger et al.	156/643
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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	R					
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	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	IBM Technical Disclosure Bulletin, MOS Gate Stack RIE With Self-Passivating Sidewalls, May 1, 1987, Vol. 29, No. 12, pp 5275-5276.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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